



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Craig A. SCHEER et al.

Application No. 10/074,354

Filed: February 11, 2002

For: PARTICLE DEPOSITION SYSTEM  
WITH ENHANCED SPEED AND  
DIAMETER ACCURACY

)  
) Docket No. SCATP001

)  
) Examiner: Y. Tadesse

)  
) Group Art Unit: 1734

)  
) Date: April 30, 2004

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on April 30, 2004.

Signed: 

Diane Schwanbeck

**REQUEST FOR RECONSIDERATION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Applicants submit this paper in response to the Final Office Action dated November 3, 2003, and in conjunction with the Request for Continued Examination being filed concurrently herewith. Applicants respectfully request reconsideration of this application in light of the following:

The **Listing of Claims**, which begins on page 2 of this paper.

Applicants' **Remarks** begin on page 6 of this paper.